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**** CONTINUING DATA *******

This application is a CIP of 10/164,327 06/05/2002 PAT 6,939,434 which is a CIP of 09/636,435
 08/11/2000 PAT 6,494,986

**** FOREIGN APPLICATIONS *********IF REQUIRED, FOREIGN FILING LICENSE GRANTED**

** 11/14/2003

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance
Verified and Acknowledged	Examiner's Signature / Initials

ADDRESS

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TITLE

Plasma immersion ion implantation process using an inductively coupled plasma source having low dissociation and low minimum plasma voltage

FILING FEE RECEIVED 2090	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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